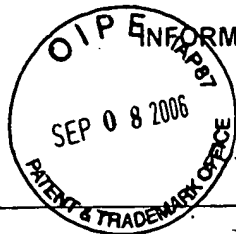


Docket Number (Optional)  
KLAC0075Application No.  
10/615,512Applicant  
Yung-Ho Chuang, et al.Filing Date  
July 7, 2003Group Art Unit  
2872INFORMATION DISCLOSURE CITATION  
IN AN APPLICATION

(Use several sheets if necessary)

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER							DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
LF	2	6	6	1	6	5	8	12/1953	Dyson			
	1	9	7	3	0	6	6	9/1934	Hauser et al.			
	4	9	7	4	0	9	4	11/1990	Morito			
	4	7	5	8	0	8	8	7/1998	Doyle			
	5	1	7	7	5	5	9	1/1993	Batchelder et al.			
	4	8	9	8	4	7	1	2/1990	Stonestrom et al.			
	5	4	2	8	4	4	2	6/1995	Lin et al.			
	5	0	3	1	9	7	6	7/1991	Shafer			
	5	7	1	7	5	1	8	2/1998	Shafer et al.			
	5	6	4	4	1	4	0	7/1997	Biedermann et al.			
	5	4	8	8	2	2	9	1/1996	Elliott et al.			
	3	2	3	7	5	1	5	3/1966	Altman			
LF	5	7	1	7	5	1	8	2/1998	Chuang			

## FOREIGN PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS													
	DOCUMENT NUMBER							DATE	COUNTRY	CLASS	SUBCLASS	Translation	
												Yes	No
LF	3	7	4	2	8	0	6	7/1989	DE				
LF	9	7	1	2	2	2	6	4/1997	WO				
LF	1	0	8	1	8	1		1/1900	DE				
LF	2	2	6	9	0	2	4	1/1994	GB				
LF	0	7	9	8	5	8	5	10/1997	EP				

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LF	M.R. Bartz et al., "LED Print Analyzer," IBM Technical Disclosure Bulletin, Vol 14, No. 3, 8/1971
LF	D.S. Goodman, "Darkfield Illuminator Attachment," IBM Technical Disclosure Bulletin, Vol. 27, No. 5, 10/1984
LF	J.L.C. Sanz et al., "Automated Visual Inspection with Dark-Field Microscopy," Journal of the Optical Society of America, November 1985, USA, Vol. 2, No. 11, pp. 1857-1862
LF	Carl Zeiss Brochure, "MSM 193 Microlithography Simulation Microscope," 1999

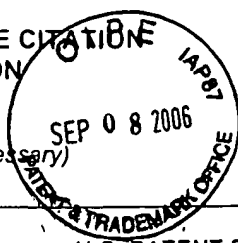
EXAMINER

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DATE CONSIDERED

10/30/2006

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

<b>FORM PTO-1449</b>  <b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b>  <i>(Use several sheets if necessary)</i>				<b>Docket Number (Optional)</b> KLAC0075		<b>Application No.</b> 10/615,512	
				<b>Applicant</b> Yung-Ho Chuang, et al.			
				<b>Filing Date</b> July 7, 2003		<b>Group Art Unit</b> 2872	

U.S. PATENT DOCUMENTS												
EXAMINER INITIAL	DOCUMENT NUMBER							DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
LF	5	1	4	0	4	5	9	8/1992	Sagan			
	5	6	3	6	0	6	6	6/1997	Takahashi			
	4	7	9	5	2	4	4	1/1989	Uehara			
	5	8	8	0	8	9	1	3/1999	Furter			
	5	3	2	3	2	6	3	6/1994	Schoenmakers			
	5	0	8	9	9	1	3	2/1992	Singh et al.			
	5	8	6	1	9	9	7	1/1999	Takahashi			
	5	5	1	5	2	0	7	5/1996	Foo			
	4	7	7	9	9	6	6	10/1988	Friedman			
	5	8	0	5	3	3	4	9/1998	Takahashi			
	5	8	0	8	8	0	5	9/1998	Takahashi			
	5	8	3	5	2	7	5	11/1998	Takahashi et al.			
LF	5	8	0	5	3	5	7	9/1998	Omura			


FOREIGN PATENT DOCUMENTS													
	DOCUMENT NUMBER							DATE	COUNTRY	CLASS	SUBCLASS	Translation	
	Yes	No											
LF	9	9	0	8	1	3	4	2/1999	WO				


OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>	

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<b>FORM PTO-1449</b>  <b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b>  (Use several sheets if necessary)	<b>Docket Number (Optional)</b> KLAC0075	<b>Application No.</b> 10/615, 512
		
<b>Applicant</b> Yung-Ho Chuang, et al.		<b>Filing Date</b> July 7, 2003
<b>Group Art Unit</b> 2872		

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LF	5 6 6 8 6 7 3	9/1997	Suenaga et al.			
	5 9 9 9 3 1 0	12/1999	Shafer et al.			
	5 1 1 4 2 3 8	5/1992	Sigler			
	4 9 7 1 4 2 8	11/1990	Moskovich			
	6 0 6 4 5 1 7	5/2000	Chuang et al.			
	6 5 4 8 7 9 7	4/2003	Ai			
	5 2 3 3 4 6 0	8/1993	Partlo			
	5 7 2 9 3 7 4	3/1998	Tiszauer et al.			
	4 1 5 5 6 3 0	5/1979	Ih			
	5 2 7 4 4 9 4	12/1993	Rafanelli et al.			
	4 5 1 1 2 2 0	4/1985	Scully			
LF	5 9 9 0 9 8 3	11/1999	Hargis et al.			
LF	5 8 0 8 7 9 7	09/1998	Bloom et al.			


**FOREIGN PATENT DOCUMENTS**

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
					Yes	No


**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**


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LF    LF	5 8 4 9 4 6 8	12/1998	Sawyer			
	5 8 5 1 7 4 0	12/1998	Sawyer			
	4 6 4 7 1 5 8	3/1987	Yeadon			
	5 4 3 4 6 6 2	7/1995	Rockwell et al.			
	5 6 2 1 5 2 9	4/1997	Gordon et al.			
	5 2 6 4 9 1 2	11/1993	Vaught et al.			
	5 3 3 7 1 7 0	8/1994	Khoury et al.			
	5 3 0 9 4 5 6	5/1994	Horton			
	6 1 9 1 8 8 7	2/2001	Michaloski et al.			
	5 1 6 2 9 3 9	11/1992	Herron et al.			
	6 2 7 5 5 1 4	8/2001	Katzir et al.			
	6 3 7 0 1 7 8	4/2002	Papayoanou et al.			

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					Yes	No

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